

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Peyman Hadizad
FILED: Concurrently Herewith
FOR: METHOD OF MAKING A VERTICAL COMPOUND
SEMICONDUCTOR FIELD EFFECT
TRANSISTOR DEVICE
Date: 7/18/2003

DISCLOSURE STATEMENT UNDER 37 C.F.R. 1.56

Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

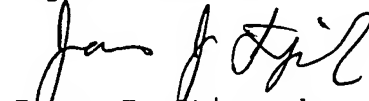
SIR:

It is respectfully requested that the prior art listed on FORM PTO-1449 be considered in the examination of the subject application and made of record therein. A copy of the listed prior art is enclosed herewith.

No representation is made or intended that the listed prior art enclosed herewith is material to patentability of the subject patent application.

No representation is made or intended that a search has been made or that no better prior art than that listed is available.

Respectfully submitted,
Peyman Hadizad



ON Semiconductor
Intellectual Property Dept.
P.O. Box 62890 - A700
Phoenix, AZ 85062-2890

James J. Stipanuk
Reg. #44,358
Phone: 602-244-4885
Fax: 602-244 3169

Customer #: 27255

Form PTO-1449 LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use Several Sheets If Necessary)	ATTY. DOCKET NO.	SERIAL NO.
	Ons00505	
	APPLICANT Peyman Hadizad	
	FILING DATE	GROUP
	CONCURRENTLY	

REFERENCE DESIGNATION U.S. PATENT DOCUMENTS

Examiner Initial	Document Number								Date	Name	Class	Sub-Class	Filing date (if appropriate)
	AA	6	3	5	6	0	5	9	3/12/2002	Yu	G05F	1/613	
	AB	5	6	1	0	0	8	5	3/11/1997	Yuan et al	H01L	21/265	
	AC	5	2	3	1	0	3	7	7/27/1993	Yuan et al	H01L	21/44	
	AD	5	2	6	2	2	9	6	4/14/1981	Shealy et al	H01L	29/06	
	AE												
	AF												
	AG												
	AH												
	AI												
	AJ												
	AK												
	AL												
	AM												

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document #	Date	Country	Class/subclass	Translation Yes - N
	AN E P 0 8 7 4 3 9 4	10/28/1998	EPO	H01L 21/337	
	AO				
	AP				
	AQ				
	AR				

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	AS	
	AT	
	AU	
	AV	
	AW	

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.